



IFW

PATENT
Docket No. 20067/OPP031475

**IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE**

Applicant(s):)	I hereby certify that this paper and the
)	documents referred to as enclosed
Geon-Ook Park)	therewith are being deposited with the
)	United States Postal Service as first
U.S. Serial No.: 10/748,652)	class mail, postage prepaid, in an
)	envelope addressed to Commissioner
For: "Method of Forming a Trench)	for Patents, P.O. Box 1450,
in a Semiconductor Device")	Alexandria, Virginia 22313-1450 on
)	this date:
Filed: 12/30/2003)	
)	<u>June 21, 2005</u>
Group Art Unit: 2812)	Date
)	
Examiner: Not Yet Assigned)	<u>Mark G. Hanley</u>
)	Mark G. Hanley
)	Attorney for Applicant(s)
)	Registration No. 44,736

STATUS LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Kindly advise when an Office action can be expected in the above-referenced matter.

Respectfully submitted,

HANLEY, FLIGHT & ZIMMERMAN, LLC
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Suite 4220
Chicago, Illinois 60606
(312) 580-1020

6/21/05
Date

By: Mark G. Hanley
Mark G. Hanley
Registration No.: 44,736